

What is claimed is:

1. A method for manufacturing an organic EL device, comprising:
coating a composition including an organic EL material above a plurality of electrodes to form an organic EL layer above each of the plurality of electrodes;
defining an effectively optical area in which the plurality of electrodes are formed; and
defining a coating area, that is broader than the effectively optical area, in which the composition including the organic EL material is to be coated.
2. The method according to claim 1, the defining a coating area step including defining the coating area to include the perimeter of the effectively optical area.
3. The method according to claim 1, the defining a coating area step including defining the coating area located along the perimeter of the effectively optical area to be a dummy area in which the composition including the organic EL material is also coated to form an organic EL layer.
4. The method according to claim 3, further comprising:
forming a layer made of the same material as that of the electrodes in the dummy area; and
coating the composition including the organic EL material on the layer.
5. The method according to claim 1, further comprising:
providing a group of effectively optical areas formed of a plurality of the effectively optical areas on a substrate; and
defining dummy areas around the effectively optical areas, respectively, and another dummy area encompassing the group of effectively optical areas.

6. The method according to claim 3, further including starting the step of coating the composition including the organic EL material at the dummy area prior to coating on the effectively optical area and ending at the dummy area after coating on the effectively optical area.

7. The method according to claim 1, further including disposing individual areas to be coated in the entirety of the coating area at a constant pitch from each other.

8. The method according to claim 7, further including disposing any one of the electrodes relative to adjacent ones of the electrodes at a constant pitch.

9. A method for manufacturing an organic EL device which includes an effectively optical area having a plurality of electrodes and an organic EL layer formed above each of the plurality of electrodes, the method comprising:

forming the organic EL layer both on areas that are to be the effectively optical area and on other areas that are not to be the effectively optical area.

10. A method for manufacturing an organic EL device which includes an effectively optical area having a plurality of electrodes and an organic EL layer formed above each of the plurality of electrodes, the method comprising:

forming the organic EL layer in areas not having the electrodes and which are supposed to be the effectively optical area.

11. An organic EL device manufactured according to the method of claim 1.